



SHEET 1 OF 1

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 251602US2		SERIAL NO. 10/821,843	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Masashi GOTO, et al.			
				FILING DATE April 12, 2004		GROUP 2 812	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
506	AW	M. GOTO, et al., Jpn. J. Appl. Phys., vol. 42, Part 1, no. 11, pages 7033-7038, "SURFACE WAVE PLASMA OXIDATION AT LOW TEMPERATURE UNDER RARE GAS DILUTION", 2003					
	AX						
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner					Date Considered 3-22-07		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 251602US2		SERIAL NO. New Application	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Masashi GOTO, et al.			
				FILING DATE Herewith		GROUP 2812	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
506	AO	11-279773	10/12/99	Japan			X
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
506	AW	M. GOTO, et al., "SURFACE WAVE PLASMA OXIDATION AT LOW TEMPERATURE FOR GATE INSULATOR OF POLY-Si TFTs", Proceedings of The Ninth International Display Workshops, December 4-6, 2002, pgs. 355 - 358.					
506	AX	Reiji MORIOKA, et al., "DEPOSITION OF HIGH-k ZIRCONIUM OXIDES IN VHF PLASMA-ENHANCED CVD USING METAL-ORGANIC PRECURSOR", Collection of Lecture Documents of the "20 th Plasma Processing Research Meeting" sponsored by Plasma Electronics Branch of Applied Physics Institute, January 29, 2003, pgs. 317 - 318.					
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner				Date Considered			
M2.4				3-27-07			

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.